

PATENT APPLICATION
Docket No. 9898-314
Client No. SS-20035-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun Lee, et al.

Serial No. Not yet assigned Examiner: Not yet assigned


Filed: January 23, 2004 Art Unit: Not yet Assigned

For: ETCHING METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

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PRELIMINARY AMENDMENT

Prior to Examination, please amend the application as follows.

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